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PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

	FSTAF	RUSHMENT OF RIGHT OF ASSIGNEE TO	O TAKE ACTION	D 2002 CENTER	_
Examiner	:	Unknown)) -	, , , ,	1 = 1
For	:	WAFER OXIDATION REACTOR AND A METHOD FOR FORMING A SEMICONDUCTOR DEVICE)))	RECE APR 3	
Filed	:	December 3, 2001)		
App. No.	:	10/007,054)		
Applicant	:	Yokouchi et al.)		

ESTABLISHMENT OF RIGHT OF ASSIGNEE TO TAKE ACTION AND REVOCATION AND POWER OF ATTORNEY

United States Patent and Trademark Office P.O. Box 2327, Arlington, VA 22202

Dear Sir:

The undersigned is empowered to act on behalf of the assignee below (the "Assignee"). A true copy of the original Assignment of the above-captioned application from the inventor(s) to the Assignee is attached hereto. This Assignment represents the entire chain of title of this invention from the Inventor(s) to the Assignee.

I declare that all statements made herein are true, and that all statements made upon information and belief are believed to be true, and further, that these statements were made with the knowledge that willful, false statements and the like so made are punishable by fine or imprisonment, or both, under 18 U.S.C. § 1001, and that willful, false statements may jeopardize the validity of the application, or any patent issuing thereon.

The undersigned hereby revokes any previous powers of attorney in the subject application, and hereby appoints the registrants of Knobbe, Martens, Olson & Bear, LLP, 620 Newport Center Drive, Sixteenth Floor, Newport Beach, California 92660, Telephone (949) 760-0404, Customer No. 20,995, as its attorneys with full power of substitution and

· App. No.

10/007,054

Filed

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December 3, 2001

revocation to prosecute this application and to transact all business in the U.S. Patent and Trademark Office connected herewith. This appointment is to be to the exclusion of the inventor(s) and his attorney(s) in accordance with the provisions of 37 C.F.R. § 3.71.

Please use Customer No. 20,995 for all communications.

THE FURUKAWA ELECTRIC Co., Ltd.

Dated: February 26, 2002

Junnosuke Furukawa

Title: President

Address: 6-1, Marunouchi 2-chome, Chiyoda-ku,

Tokyo 100-8322 Japan

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PATENT

ASSIGNMEDO NOT RECORD -

WHEREAS, I/WE (1) Noriyuki YOKOUCHI				
a Japanese	citizen, residing at <u>Tokyo, Japan</u>			
(2) Natsumi UEDA				
	citizen, residing at <u>Tokyo, Japan</u>			
(3) Yasumasa SASAKI				
a Japanese	citizen, residing atTokyo, Japan			
(4) Fumio KOYAMA				
a Japanese	citizen, residing at Tokyo, Japan			
(5) Kenichi IGA				
a Japanese	citizen, residing at Tokyo, Japan			
(6)	,			
a	citizen, residing at			
(7)	,			
a	citizen, residing at			
(8)	,			
a	citizen, residing at			
	gnor (collectively if more than one inventor is listed above), have invented certain new WAFER OXIDATION REACTOR AND A METHOD			
and useful improvements in_	FOR FORMING A SEMICONDUCTOR DEVICE			
the specification of which:	,			

(a) is attached hereto; or

	(b)		was filed on	Decer	nber 3, 200) <u>1</u>	as Application
			No			or Express Mail N	lo., as Application No. not
			yet known	EL8712	276915US		and was amended
			on				(if applicable); or
	(c)	٥	was described an	d claime	d in PCT Interr	ational Application No) .
						filed on	
			and as amended	under PC	T Article 19 or	l <u></u>	
			(if any) and/or ur	nder PCT	Article 34 on		(if any).
	AND W	HEREAS	THE FURU	KAWA E	LECTRIC CO	., LTD.	
with it	ts princip	al nlace	of husiness at	6-1, N	Marunouchi	2-chome, Chiyod	a-ku, Tokyo 100-8322
						re right, title, and into	terest in and to the said
oresent assigns and un enewa and all nereby	s does he, the entire der said i ls and con reissues a authorizes provementent.	reby sell e right, ti improven itinuation and exter s and requ ts to Assi	, assign, transfer tle, and interest in nents, and any Pa s thereof, and all assions thereof, an uests the Commissi gnee, its successo	and set in the Unitatent Ap Patents of ad all rig sioner of ors, legal	over, unto As- ited States of A plications in the of the United S hts of priority Patents of the representatives	signee, its successors, america, and its territor the United States of A states of America which under International Counted States of America and assigns, in accordance	legal representatives and ries and possessions in, to merica and all divisions, h may be granted thereon onventions; and Assignor ica to issue all Patents for ance with the terms of this Assignee, its successors,
oroceed and ger	epresentati ling, sign a nerally do	ives and all lawful everythin	assigns, any fact papers, execute a g possible to aid	s known all division Assignee	to it respectional, continuing to, its successors	ng said improvements, and reissue application	and testify in any legal ns, make all rightful oaths and assigns, to obtain and
IN TESTIMONY WHEREOF, Assignor intending to be legally bound has hereunto affixed its signature.							
Γhis <u>1</u>	<u>Oth</u> day	of Dec	ember, 2	20_01	Signature of	Moriyuki YOKOL	JCHI .
This	0th day	De of	cember , 2	20_01_	Nats Signature of	umi' Ueda Natsumi UEDA	1
Γhis <u>1</u>	0th day	of <u>D</u> ∈	ecember, 2	2001	Signature of	Yasumasa SASAKI	

Japan

This 10th	day of December	, 20_01_	Signature of Furnio KOYAMA
This 10th	day of <u>December</u>	, 20 <u>01</u>	Signature of Kenichi IGA
This	_ day of	, 20	Signature of
This	. day of	, 20	Signature of
This	day of,	20	Signature of